



Attorney Docket
32739 M 008

#24
Amdt E
DSM 115-Logan
4/30/03
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO. 5926

Applicant : Kensuke FUJIWARA
Serial No. : 09/280,518
Filed : April 5, 1999
For : LASER INTENSITY ADJUSTING METHOD
Art Unit : 2861
Examiner : Hai Chi PHAM

RESPONSE TO PAPER NO. 23

Commissioner for Patents
Washington, DC 20231

Sir :

This paper is submitted in reply to the Office Action of January 28, 2003 (Paper No. 23). Please accept this paper as timely filed.
Please amend this application as follows.

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